

REPLACEMENT DRAWINGS

Inventor: Gilyong Chung, et al.

Docket No.: 14506-44054

Title: Inclusion of Nitrogen At the Silicon Dioxide-Silicon  
Carbide Interface for Passivation of Interface Defects

Serial No. 09/818,193

Attorney Name: Tim Tingkang Xia

Phone No.: 404-495-3678 Sheet 1 of 6



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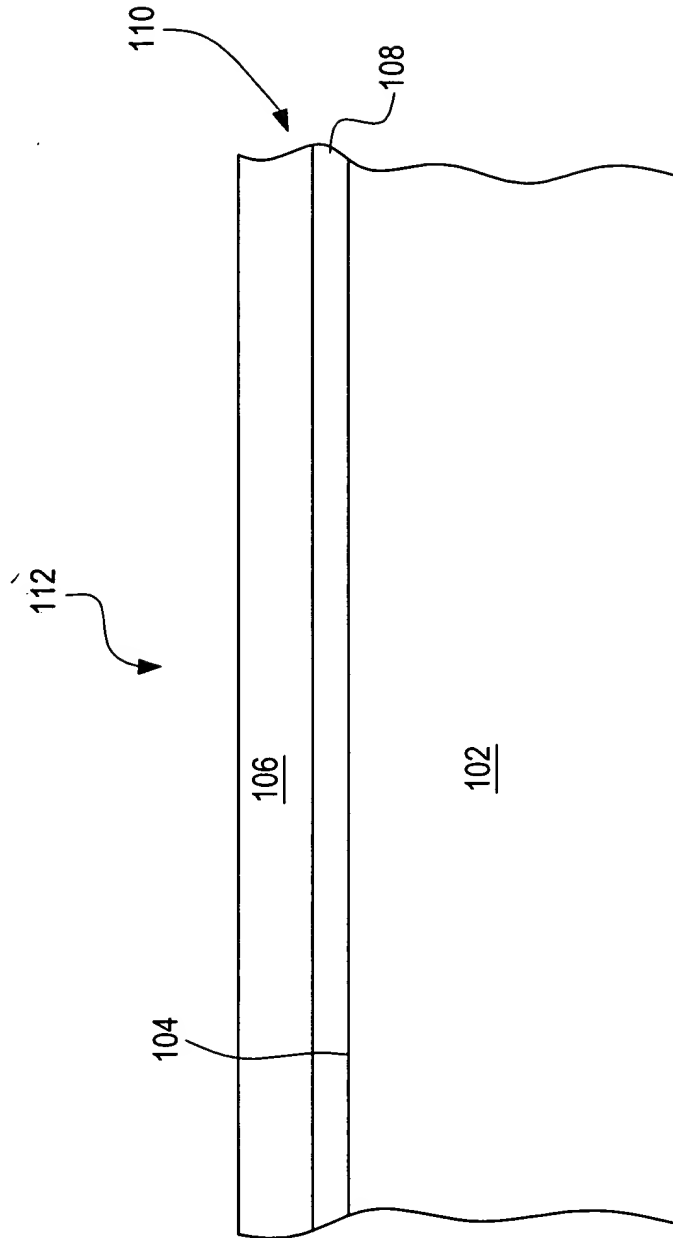


FIGURE 1

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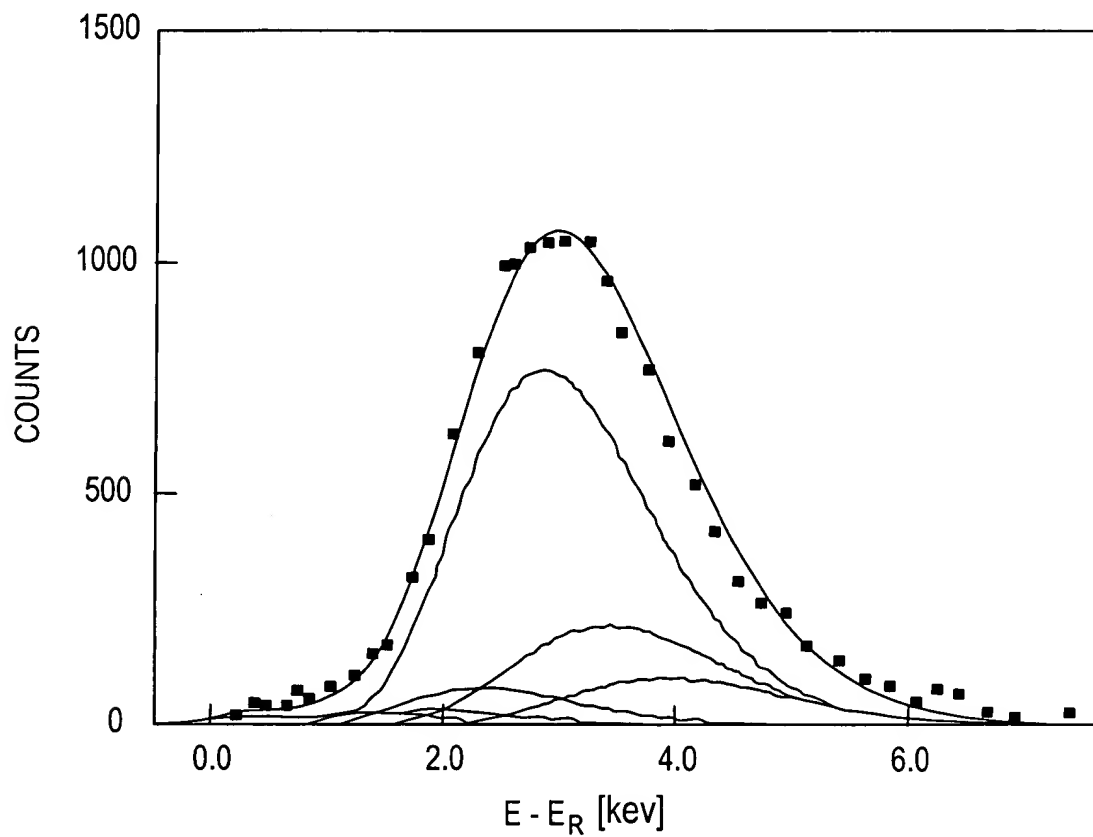


FIGURE 2

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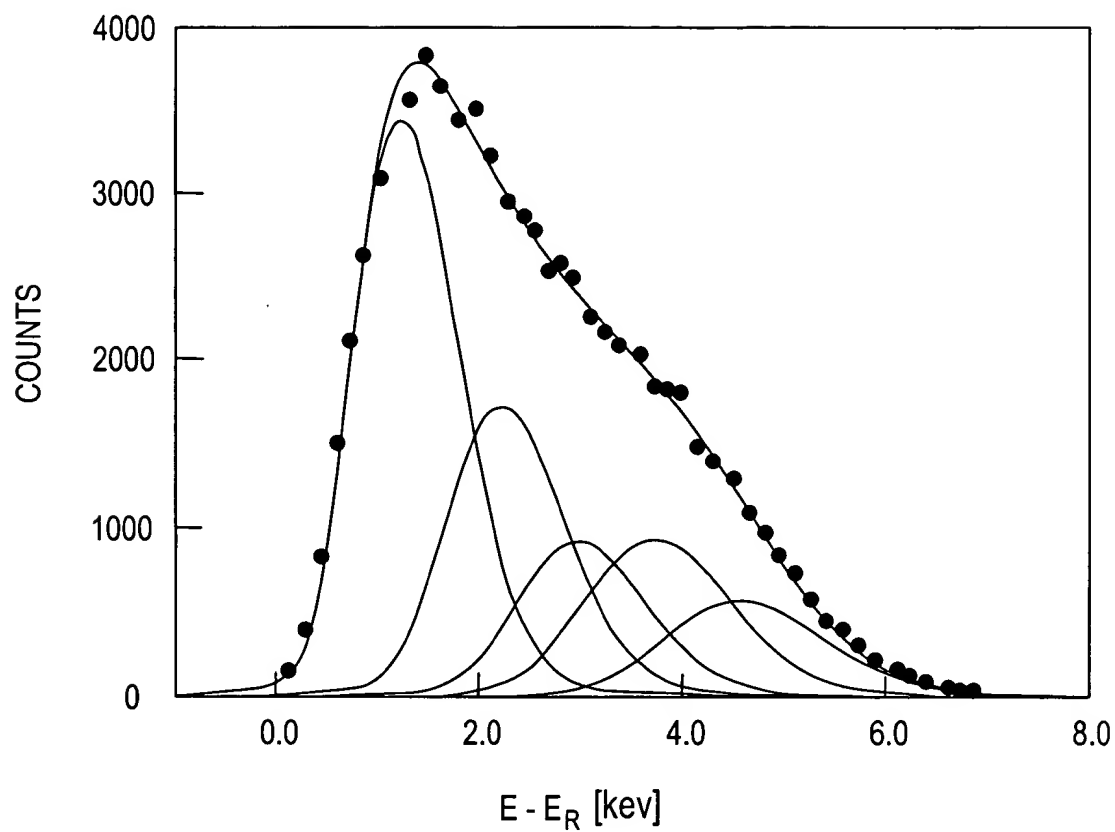


FIGURE 3

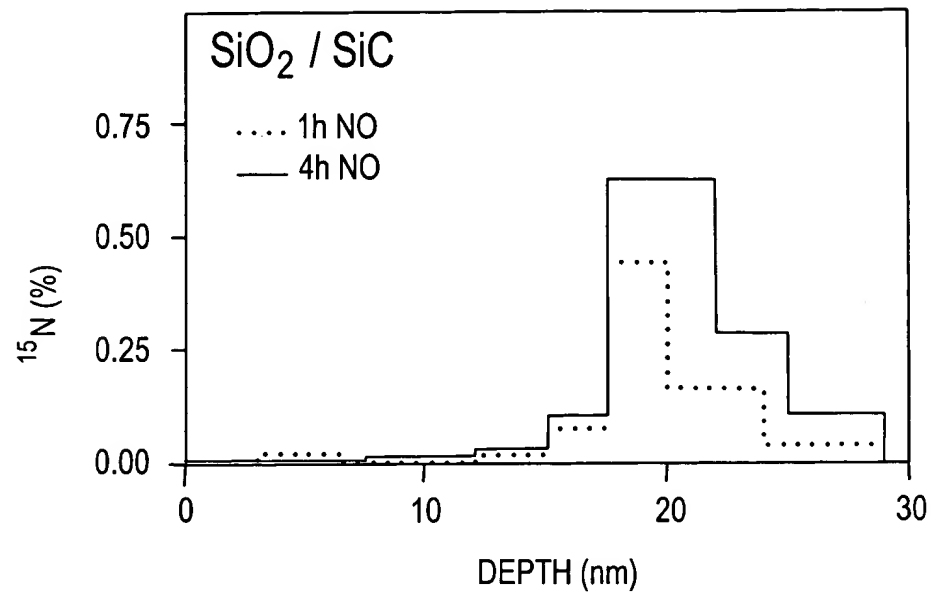


FIGURE 4

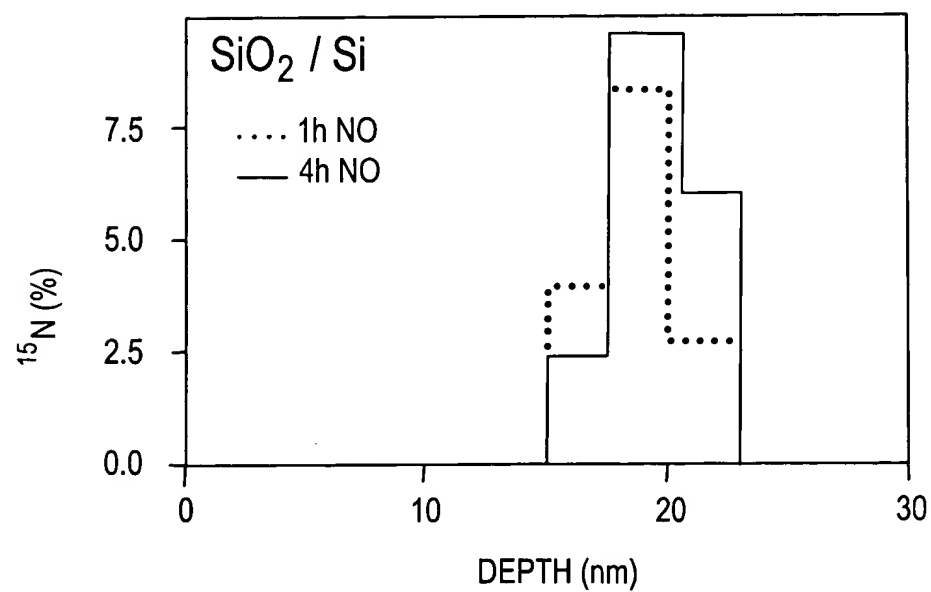


FIGURE 5

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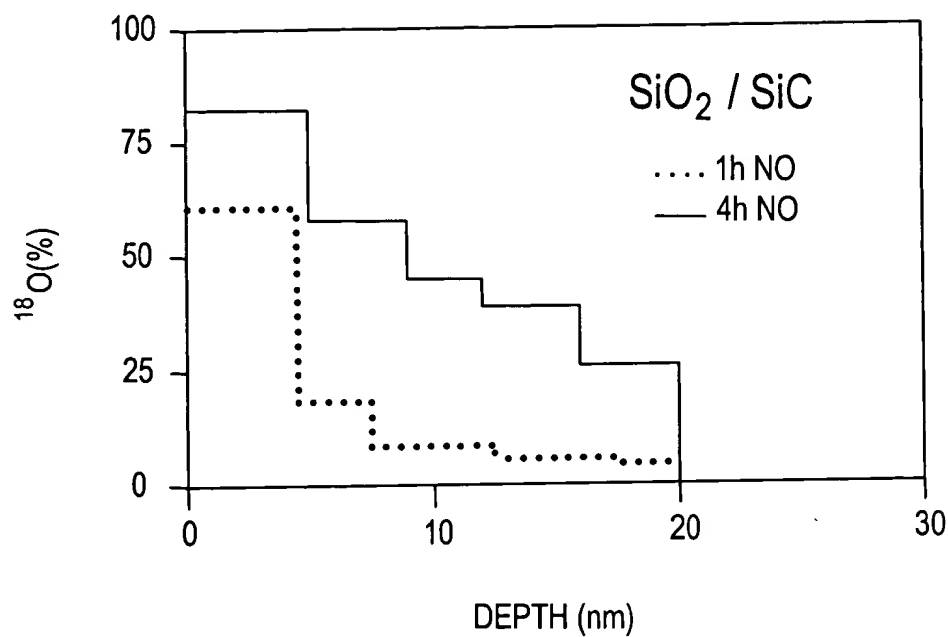


FIGURE 6

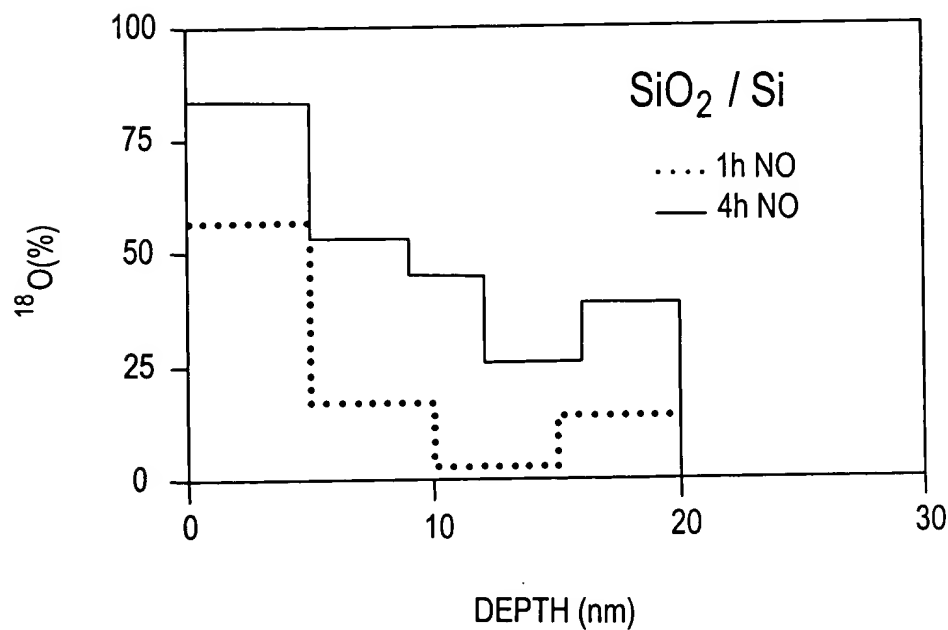


FIGURE 7

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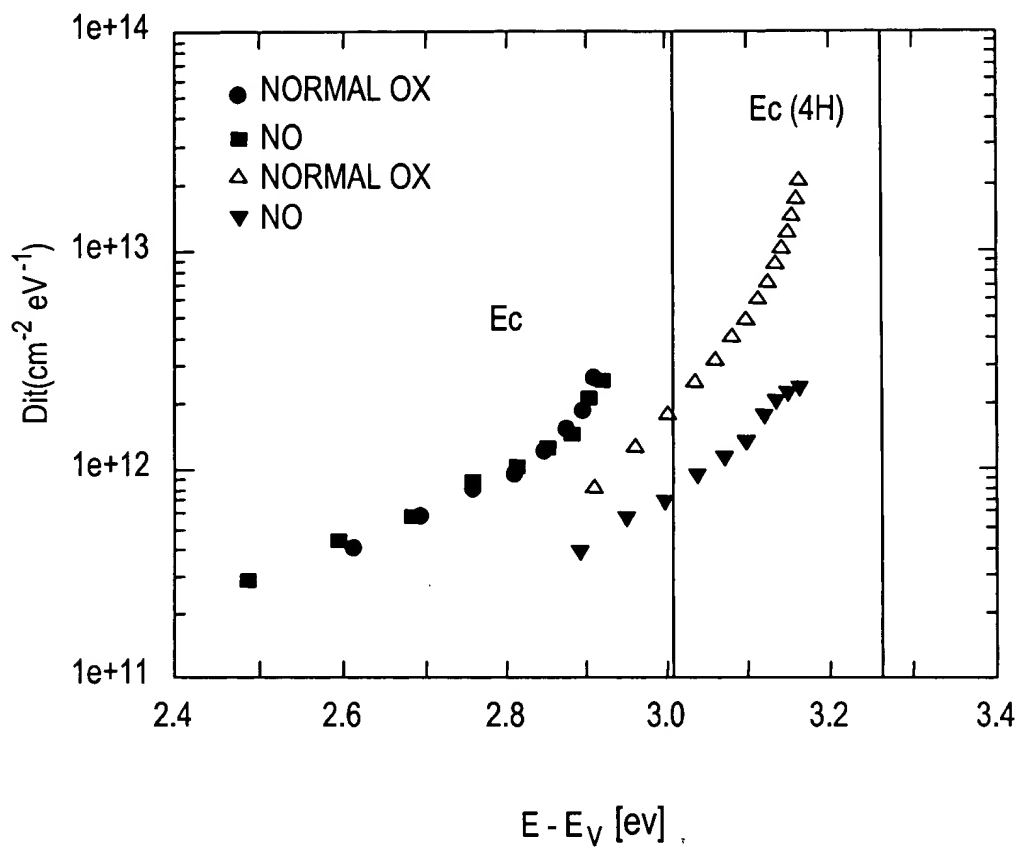


FIGURE 8